

10/581674

AP3 Rec'd PCT/PTO 05 JUN 2008

## Application Data Sheet

### Application Information

Application number::

Filing Date::

Application Type::

Subject Matter::

Title ::

Regular

Utility

METHOD FOR  
MANUFACTURING THIN  
FILM INTEGRATED CIRCUIT  
DEVICE, NONCONTACT  
THIN FILM INTEGRATED  
CIRCUIT DEVICE AND  
METHOD FOR  
MANUFACTURING THE  
SAME, AND IDTAG AND  
COIN INCLUDING THE  
NONCONTACT THIN FILM  
INTEGRATED CIRCUIT  
DEVICE

Attorney Docket Number::

0756-7719

Total Drawing Sheets::

23

Small Entity?::

No

### Applicant Information

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Inventor

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## Representative Information

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## Domestic Priority Information

Application ::	Continuity Type::	Parent Application::	Parent Filing Date::
This application	National Stage	PCT/JP2004/018978	12/14/2004

## Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::
Japan	2003-417317	12/15/2003	Yes

## Assignee Information

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